

---

---

**Vacuum technology — Vocabulary —  
Part 2:  
Vacuum pumps and related terms**

*Technique du vide — Vocabulaire —*

*Partie 2: Pompes à vide et termes associés*



This document is a preview generated by ERS



# **COPYRIGHT PROTECTED DOCUMENT**

© ISO 2020

All rights reserved. Unless otherwise specified, or required in the context of its implementation, no part of this publication may be reproduced or utilized otherwise in any form or by any means, electronic or mechanical, including photocopying, or posting on the internet or an intranet, without prior written permission. Permission can be requested from either ISO at the address below or ISO's member body in the country of the requester.

ISO copyright office  
CP 401 • Ch. de Blandonnet 8  
CH-1214 Vernier, Geneva  
Phone: +41 22 749 01 11  
Fax: +41 22 749 09 47  
Email: [copyright@iso.org](mailto:copyright@iso.org)  
Website: [www.iso.org](http://www.iso.org)

Published in Switzerland

Contents		Page
Foreword.....		iv
1	Scope .....	1
2	Normative references .....	1
3	Terms and definitions .....	1
3.1	Vacuum pumps.....	1
3.2	Parts of vacuum pumps .....	7
3.3	Accessories.....	9
3.4	Categories of vacuum pumps with reference to operation.....	10
3.5	Characteristics of vacuum pumps.....	11
Annex A (informative) Classification table of vacuum pumps .....		14

## Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see [www.iso.org/directives](http://www.iso.org/directives)).

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. ISO shall not be held responsible for identifying any or all such patent rights. Details of any patent rights identified during the development of the document will be in the Introduction and/or on the ISO list of patent declarations received (see [www.iso.org/patents](http://www.iso.org/patents)).

Any trade name used in this document is information given for the convenience of users and does not constitute an endorsement.

For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT) see [www.iso.org/iso/foreword.html](http://www.iso.org/iso/foreword.html).

This document was prepared by Technical Committee ISO/TC 112, *Vacuum technology*.

This second edition cancels and replaces the first edition (ISO 3529-2:1981), which has been technically revised. The main changes compared to the previous edition are as follows:

- under positive displacement pumps are added diaphragm-, peristaltic-, scroll-, screw-, claw- and trochoid vacuum pumps;
- under kinetic vacuum pumps are added regenerative- and compound turbo vacuum pump;
- under gas entrapment or capture vacuum pumps different types of condensers are added;
- under parts, categories and characteristics of vacuum pumps are added some new actual used definitions.

A list of all parts in the ISO 3529 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at [www.iso.org/members.html](http://www.iso.org/members.html).

# Vacuum technology — Vocabulary —

## Part 2:

## Vacuum pumps and related terms

### 1 Scope

This document gives definitions of vacuum pumps and related terms. It is a continuation of ISO 3529-1 which defines general terms used in vacuum technology.

### 2 Normative references

ISO 3529-1:2019, *Vacuum technology — Vocabulary — Part 1: General terms*

ISO 21360-1:2012, *Vacuum technology — Standard methods for measuring vacuum-pump performance — Part 1: General description*

### 3 Terms and definitions

For the purposes of this document, the following terms and definitions apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <https://www.iso.org/obp>
- IEC Electropedia: available at <http://www.electropedia.org/>

#### 3.1 Vacuum pumps

##### 3.1.1

##### **vacuum pump**

device for creating, improving and/or maintaining a vacuum

Note 1 to entry: Two basically distinct categories may be considered: *gas transfer pumps* (3.1.2) and *gas gathering vacuum pumps* (3.1.32)

Note 2 to entry: Some definitions given in ISO 3529-1 are repeated in this document in different terms to adapt to vacuum pumps.

Note 3 to entry: Vacuum is defined in ISO 3529-1.

Note 4 to entry: A classification table for vacuum pumps is described in [Annex A](#).

##### 3.1.2

##### **gas transfer vacuum pumps**

*vacuum pump* (3.1.1) that transports gas molecules from the inlet to the *outlet* (3.2.3) of the vacuum pump by means of positive displacement or transfer of kinetic momentum